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Docket No.: 2328-053

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	EXPEDITED PROCEDURE	<i>Entered with ROE 8/19/15 MW 9/2/15</i>
Tuqiang NI et al.	:	Response under 37 CFR 1.116	
	:	Confirmation No. 5171	
	:		
U.S. Patent Application No. 09/821,753	:	Group Art Unit: 1763	
Filed: March 30, 2001	:	Examiner: ALEJANDRO MULERO, LULZ L.	
For: PLASMA PROCESSING METHOD AND APPARATUS WITH CONTROL OF PLASMA EXCITATION POWER			

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

December 20, 2004

Sir:

This paper is submitted in reply to the Office Action mailed October 19, 2004, which was made Final. Applicants respectfully request that the following amendments be entered to place this application in condition for allowance.

I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-
LE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE

ON THE DATE SHOWN BELOW

Alice Weaver
TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION

Alice Weaver 12-20-04
SIGNATURE DATE

(762) 872-9306
SIGNATURE DATE